Refine Search

Search Results -

Terms	Documents
(manufactur$4 or fabracat$ or product) and (semiconductor or wafer or substrate) and load$4 near4 request$ same (setpoint or threshold or target or predetermined)	63

Database:

```
US Pre-Grant Publication Full-Text Database
US Patents Full-Text Database
US OCR Full-Text Database
EPO Abstracts Database
JPO Abstracts Database
Derwent World Patents Index
IBM Technical Disclosure Bulletins
```

Search:

```
L2
```

[Refine Search]

[Recall Text ⬍]   [Clear]   [Interrupt]

Search History

DATE: Friday, August 06, 2004   Printable Copy   Create Case

Set Name side by side	Query	Hit Count	Set Name result set
	DB=USPT; PLUR=YES; OP=ADJ		
L2	(manufactur$4 or fabracat$ or product) and (semiconductor or wafer or substrate) and load$4 near4 request$ same (setpoint or threshold or target or predetermined)	63	L2
L1	(manufactur$4 or fabracat$ or product) and (semiconductor or wafer or substrate) and load$4 near4 request$	702	L1

END OF SEARCH HISTORY